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PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : SOPHIE et al.

App. No. : 09/975,466

: October 9, 2001

For : IN SITU REDUCTION OF

COPPER OXIDE PRIOR TO SILICON CARBIDE

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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Dear Sir:

Enclosed is form PTO-1449 listing five (5) references that are also enclosed. This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required in accordance with 37 C.F.R. § 1.97(b)(3). If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: March 1, 2002

By: _

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